

APPLICATION DATA SHEET

Application Information

Application Type:: Regular
Subject Matter:: Utility
Title:: SEMICONDUCTOR SUBSTRATE,
SEMICONDUCTOR DEVICE AND PROCESS
FOR PRODUCING SEMICONDUCTOR
SUBSTRATE
Attorney Docket No:: 60562.00009
Total Drawing Sheets:: 19
Request for Early Publication?:: No
Request for Non-Publication?:: No
Small Entity:: Yes
Secrecy Order in Parent Appln?:: No

Applicant Information

Applicant Authority Type:: Inventor
Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Tetsushi
Middle Name::
Family Name:: SAKAI
City of Residence:: Yokohama
State or Province of Residence::
Country of Residence:: Japan
Street of Mailing Address:: c/o Tokyo Institute of Technology
4259, Nagatsuta-cho, Midori-ku

City of Mailing Address:: Yokohama-shi
State or Province of Mailing Address:: Kanagawa
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 226-8503

Applicant Authority Type:: Inventor
Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Shunichiro
Middle Name::
Family Name:: OHMI
City of Residence:: Yokohama
State or Province of Residence::
Country of Residence:: Japan
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State or Province of Mailing Address:: Kanagawa
Country of Mailing Address:: Japan
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Applicant Authority Type:: Inventor
Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Takashi
Middle Name::
Family Name:: YAMAZAKI
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State or Province of Residence::
Country of Residence:: Japan

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State or Province of Mailing Address:: Kanagawa
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 2268503

Correspondence Information

Correspondence Customer Number:: 32294

Representative Information

Representative Customer Number:: 32294

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP2004/014603	10/04/04

Foreign Priority Information

Country:: Japan
Application No:: 2003-352692
Filing Date:: 10/10/03
Priority Claimed:: Yes

Assignment Information

Assignee Name:: TOKYO INSTITUTE OF TECHNOLOGY